

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

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Docket Number (Optional)

01P21904

Application Number

10/606,211

Applicant(s)

Michael Weirich

Filing Date

06/26/2003

Group Art Unit

2821

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TC		5,498,995	03/12/1996	Szepesi et al.	327	538	12/13/1994
TC		5,757,627	05/26/1998	Faulk	363	21	12/31/1996
TC		6,301,135 B1	10/09/2001	Mammano et al.	363	95	12/30/1999

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
TC		WO 01/26213 A1	04/12/2001	WIPO	H03B	5/12		✓
TC		WO 01/61832 A2	08/23/2001	WIPO	H02M			✓
TC		EP 0230930	08/05/1987	European Patent Office (EPO)	H02M	3/335		✓
TC		JP 01004102 (abstract)	01/09/1989	Japan (via EPO)	H03B	5/36		✓
TC		JP 05315956 (abstract)	11/26/1993	Japan (via EPO)	H03L	7/24		✓

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

TC		Copy of Search Report (5 pages) for corresponding European application; search report was issued by the European Patent Office on November 17, 2004.

EXAMINER

*Seandubh. 00*

DATE CONSIDERED

2/9/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.